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Substitute for form 1449A/PTO				Complete if Known	
 INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)				Application Number	09/920,341
				Filing Date	08/01/2001
				First Named Inventor	Choi et al.
				Group Art Unit	2877
				Examiner Name	Sang H. Nguyen
				Attorney Docket Number	PA17-07V06
Sheet	1	of	6		

U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			

8N	J1	5,425,848		Haisma et al.	6/20/1995	
↑	J2	6,309,580	B1	Chou	10/30/2001	
	J3	6,391,217	B2	Schaffer et al.	5/21/2002	
	J4	2002/0177319	A1	Chou	11/28/2002	
	J5	6,713,238	B1	Chou et al.	3/30/2004	
	J6	6,518,189	B1	Chou	2/11/2003	
	J7	2004/0192041	A1	Jeong et al.	9/30/2004	
	J8	5,726,548		Chiba et al.	3/10/1998	
	J9	2002/0069525	A1	Hada et al.	6/13/2002	
	J10	5,508,527		Kuroda et al.	4/16/1996	
	J11	5,876,550		Feygin et al.	3/2/1999	
	J12	5,785,918		Hull	7/28/1998	
	J13	5,171,490		Fudim	12/15/1992	
	J14	6,828,244	B2	Chou	12/7/2004	
	J15	6,809,356	B2	Chou	10/26/2004	
	J16	5,737,064		Inoue et al.	4/7/1998	
↓	J17	2004/0197843	A1	Chou et al.	10/7/2004	
8N	J18	2004/0156108	A1	Chou et al.	8/12/2004	

Examiner Signature	<i>Sang H. Nguyen</i>	Date Considered	04/09/05
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SN	J19	2004/0137734	A1	Chou et al.	7/15/2004	
↑	J20	2004/0131718	A1	Chou et al.	7/8/2004	
	J21	2004/0118809	A1	Chou et al.	6/24/2004	
	J22	2004/0046288	A1	Chou	3/11/2004	
	J23	2003/0080472	A1	Chou	5/1/2003	
	J24	2003/0034329	A1	Chou	2/20/2003	
	J25	2002/0042027	A1	Chou et al.	4/11/2002	
	J26	6,636,311	B1	Ina et al.	10/21/2003	
	J27	6,383,888	B1	Stirton	5/7/2002	
	J28	2004/0033515	A1	Cao et al.	2/19/2004	
	J29	2004/0189996	A1	Sreenivasan et al.	9/30/2004	
	J30	6,630,410	B2	Trapp et al.	10/7/2003	
	J31	6,580,172	B2	Mancini et al.	6/17/2003	
	J32	10/670,980		Sreenivasan et al.	9/25/2003	
	J33	10/895,214		Voison	7/20/2004	
	J34	11/000,321		Nimmakayala et al.	11/30/2004	
↓	J35	4,512,848		Deckman et al.	4/23/1985	
SN	J36	6,791,669	B2	Poon	9/14/2004	

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		Office 3	Number ⁴	Kind Code ⁵ (if known)				

SN	J44	WO	2004/016406		Sreenivasan	2/26/2004		
↑	J45	WO	02/07199		Chou	1/24/2002		
	J46	WO	2004/114016		Chou et al.	12/29/2004		
	J47	WO	99/05724		Chou et al.	2/4/1999		
	J48	WO	03/010289		Chou et al.	2/6/2003		
	J49	WO	03/079416		Chou	9/25/2003		
↓	J50	WO	03/099536		Chou et al.	12/4/2003		
SN	J51	WO	2004/013693		Watts	2/12/2004		

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				Group Art Unit	2877
				Examiner Name	Sang H. Nguyen
				Attorney Docket Number	PA17-07V06
Sheet	5	of	6		

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
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SN ↑ SN	J52	Chou, Nanoimprint Lithography and Lithographically Induced Self-Assembly, MRS Bulletin, pp. 512 - 517, 7/1/2001	
	J53	Colburn et al., Step and Flash Imprint Lithography for sub-100 nm Patterning, Proceedings of SPIE Vol. 3997, pp. 453 - 457, 1/1/2000	
	J54	Johnson et al., Advances in Step and Flash Imprint Lithography, SPIE Microlithography Conference, 2/23/2003	
	J55	Chou et al., Ultrafast and Direct Imprint of Nanostructures in Silicon, Nature, Vol. 417, (June 2002), pp. 835-837, 6/1/2002	
	J56	Chou et al., Nanoimprint Lithography, Journal of Vacuum Science Technology B 14(16), pp. 4129-4133, 11/1/1996	
	J57	Colburn et al., Development and Advantages of Step-and-Flash Lithography, Solid State Technology, 7/1/2001	
	J58	Colburn et al., Characterization and Modeling of Volumetric and Mechanical Properties for Step and Flash Imprint Lithography Photopolymers, Journal of Vacuum Science Technology. Vol. b. 19(6), 11/1/2001	
	J59	Bailey et al., Step and Flash Imprint Lithography: Defect Analysis, Journal of Vacuum Science, B 19(6), pp. 2806-2810, 11/1/2001	
	J60	Bailey et al., Step and Flash Imprint Lithography: Template Surface Treatment and Defect Analysis, Journal of Vacuum Science, B 18(6), pp. 3572-3577, 11/1/2000	

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				Application Number	09/920,341
				Filing Date	08/01/2001
				First Named Inventor	Choi et al.
				Group Art Unit	2877
				Examiner Name	Sang H. Nguyen
				Attorney Docket Number	PA17-07V06
Sheet	6	of	6		

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
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SN	J61	Wronosky et al., Wafer and Reticle Positioning System for the Extreme Ultraviolet Lithography Engineering Test Stand, Emerging Lithography Technologies, Proceedings of SPIE Vol. 3997, pp. 829-839, 7/1/2000	
SN	J62	Schneider et al., Stripes of Partially Fluorinated Alkyl Chains: Dipolar Langmuir Monolayers,	

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		First Named Inventor	Byung J. Choi
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		Attorney Docket Number	PA17-07V06

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		Number	Kind Code* (if known)			
CN	11	6,049,373		Miyatake et al.	4/11/2000	
	12	2002/0094496	A1	Choi et al.	7/18/2002	
	13	2002/0098426	A1	Sreenivasan et al.	7/25/2002	
	14	2002/0150398	A1	Choi et al.	10/17/2002	
	15	2004/0149687	A1	Choi et al.	8/5/2004	
	16	2003/0215577	A1	Willson et al.	11/20/2003	
	17	2004/0007799	A1	Choi et al.	1/15/2004	
	18	2004/0008334	A1	Sreenivasan et al.	1/15/2004	
	19	2004/0021254	A1	Sreenivasan et al.	2/5/2004	
	110	2004/0021866	A1	Watts et al.	1/5/2004	
	111	2004/0124566	A1	Sreenivasan et al.	7/13/2004	
	112	2004/0141163	A1	Bailey et al.	7/22/2004	
	113	2004/0163563	A1	Bailey et al.	8/26/2004	
	114	2004/0251775	A1	Choi et al.	12/16/2004	
	115	2004/0009673	A1	Sreenivasan et al.	1/15/2004	
	116	2004/0022888	A1	Sreenivasan et al.	2/5/2004	
	117	2004/0168588	A1	Choi et al.	9/2/2004	
	118	2004/0086793	A1	Sreenivasan et al.	5/6/2004	
	119	2004/0104641	A1	Choi et al.	6/3/2004	
	120	2004/0168586	A1	Bailey et al.	9/2/2004	
	121	2004/0169441	A1	Choi et al.	9/2/2004	
	122	2004/0170771	A1	Bailey et al.	9/2/2004	
	123	2004/0189994	A1	Sreenivasan et al.	9/30/2004	
	124	2004/0209177	A1	Sreenivasan et al.	9/30/2004	
	125	2004/0200411	A1	Willson et al.	10/14/2004	
	126	2004/0053146	A1	Sreenivasan et al.	10/21/2004	

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SN	135	U.S. App. No. 09/698317, filed 10/27/2000, entitled: High Precision Orientation Alignment and Gap Control Stages for Imprint Lithography Processes, naming inventors Byung Choi et al.	
↑	136	U.S. App. No. 10/614716, filed 7/7/2003, entitled: Conforming Template for Patterning Liquids Disposed on Substrates, naming inventors Sreenivasan et al.	
	137	U.S. App. No. 10/785248, filed 2/24/2004, entitled: Method to Control the Relative Position Between a Body and a Substrate, naming inventors Sreenivasan et al.	
	138	U.S. App. No. 10/864214, filed 6/9/2004, entitled: Imprint Lithography System to Produce a Light to Impinge upon and Polymerize a Liquid in Superimposition with Template Overlay Marks, naming inventors Sreenivasan et al.	
SN	139	Abstract of Japanese Patent 63-194956	

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Group Art Unit	2877
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Examiner Name	Nguyen, Sang H.
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U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
S W	G1	4,119,688		Hiraoka	10-10-1978	
	G2	4,208,240		Latos	06-17-1980	
	G3	4,707,611		Southwell	11-17-1987	
	G4	4,776,695		Van Pham et al.	10-11-1988	
	G5	5,048,960		Hayashi et al.	09-17-1991	
	G6	5,160,402		Cheng	11-03-1992	
	G7	5,270,222		Moslehi	12-14-1993	
	G8	5,335,066		Yamada et al.	08-02-1994	
	G9	5,374,327		Imahashi et al.	12-20-1994	
	G10	5,386,119		Ledger	01-31-1995	
	G11	5,403,433		Morrison et al.	04-04-1995	
	G12	5,493,401		Horie et al.	02-20-1996	
	G13	5,565,114		Saito et al.	10-15-1996	
	G14	5,643,364		Zhao et al.	07-01-1997	
	G15	5,686,993		Kokubo et al.	11-11-1997	
	G16	5,694,207		Hung et al.	12-02-1997	
	G17	5,719,495		Moslehi	02-17-1998	
	G18	5,877,032		Guinn et al.	03-02-1999	
	G19	5,885,472		Miyazaki et al.	03-23-1999	
	G20	5,983,906		Zhao et al.	11-16-1999	
	G21	6,052,183		Lee	04-18-2000	
	G22	6,068,783		Szetsen	05-30-2000	
	G23	6,278,519		Rosencwaig et al.	08-21-2001	
	G24	6,278,809		Johnson et al.	08-21-2001	
	G25	6,297,880		Rosencwaig et al.	10-02-2001	
	G26	6,304,326		Aspnes et al.	10-16-2001	
	G27	6,633,391		Oluseyi et al.	10-14-2003	
	G28	6,603,538		Oluseyi et al.	08-05-2003	
	G29	6,081,334		Grimbergen et al.	06-27-2000	
	S W	G30	6,753,972	B1	Hirose et al.	06-22-2004
G31		2003/0133126	A1	Sarfaty et al.	07-17-2003	
Examiner Signature	Sandwich			Date Considered	05/11/05	

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PTO/SB/08A (08-00)

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Complete if Known

Application Number	09/920,341
Filing Date	08/01/2001
First Named Inventor	Choi et al.
Group Art Unit	2877
Examiner Name	Nguyen, Sang H.
Attorney Docket Number	PA17-07V06

Sheet 2 of 3

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>		Complete if Known	
		Application Number	09/920,341
		Filing Date	08/01/2001
		First Named Inventor	Choi et al.
		Group Art Unit	2877
		Examiner Name	Nguyen, Sang H.
Attorney Docket Number	PA17-07V06		
Sheet	3	of	3

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
SN	G34	Communication Relating to the Results of the Partial International Search; International Appl. No. PCT/US2002/015551.	
↑	G35	Papirer et al., "The Grafting of Perfluorinated Silanes onto the Surface of Silica: Characterization by Inverse Gas Chromatography," August 1993, pp238-242, vol. 159, Issue 1.	
	G36	Abstract of Papirer et al., "The Grafting of Perfluorinated Silanes onto the Surface of Silica: Characterization by Inverse Gas Chromatography," August 1993, pp238-242, vol. 159, Issue 1.	
	G37	Hirai et al., "Mold Surface Treatment for Imprint Lithography," August 2001, pp 457-462, vol 14, No. 3.	
	G38	Abstract of Hirai et al., "Mold Surface Treatment for Imprint Lithography," August 2001, pp 457-462, vol 14, No. 3.	
	G39	Sung et al., "Micro/nano-tribological Characteristics of Self-Assembled Monolayer and its Application in Nano-Structure Fabrication," July 2003, pp. 808-818, vol. 255, no. 7.	
↓	G40	Abstract of Sung et al., "Micro/nano-tribological Characteristics of Self-Assembled Monolayer and its Application in Nano-Structure Fabrication," July 2003, pp. 808-818, vol. 255, no. 7.	
	G41	Roos et al., "Nanoimprint Lithography with a Commerical 4 Inch Bond System for Hot Embossing," October 2001, pp. 427-435, vol. 4343.	
	G42	Abstract of Roos et al., "Nanoimprint Lithography with a Commerical 4 Inch Bond System for Hot Embossing," October 2001, pp. 427-435, vol. 4343.	
SN	G43	Office Action for United States Patent Application 10/053,357 dated 12/16/2003	

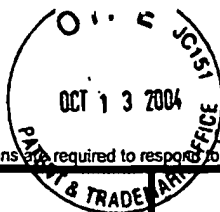
Examiner Signature	Sang H. Nguyen	Date Considered	04/11/05
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Substitute for form 1449A/PTO				Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)				Application Number	09/920,341
				Filing Date	08/01/2002
				First Named Inventor	Choi et al.
				Group Art Unit	2877
				Examiner Name	Nguyen, Sang H.
Sheet	1	of	7	Attorney Docket Number	PA17-07V06

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		Number	Kind Code ³ (if known)			
SN ↑	E1	4,070,116		Frosch et al.	01-24-1978	
	E2	4,600,309		Fay	07-15-1986	
	E3	4,848,911		Uchida et al.	07-18-1989	
	E4	5,074,667		Miyatake	12-24-1991	
	E5	5,148,036		Matsugu et al.	09-15-1992	
	E6	5,148,037		Suda et al.	09-15-1992	
	E7	5,151,754		Ishibashi et al.	09-29-1992	
	E8	5,179,863		Uchida et al.	01-19-1993	
	E9	5,376,810		Hoenk et al.	12-27-1994	
	E10	5,424,549		Feldman	06-13-1995	
	E11	5,670,415		Rust	09-23-1997	
	E12	5,743,998		Park	04-28-1998	
	E13	5,855,686		Rust	01-05-1999	
	E14	5,948,219		Rohner	09-07-1999	
	E15	6,035,805		Rust	03-14-2000	
	E16	6,150,680		Eastman et al.	11-21-2000	
	E17	6,326,627	B1	Putvinski et al.	12-04-2001	
	E18	2002/0132482	A1	Chou	09-19-2002	
	E19	2002/0167117	A1	Chou	11-14-2002	
	E20	6,482,742	B1	Chou	11-19-2002	
	E21	6,534,418	B1	Plat et al.	03-18-2003	
	E22	6,541,360	B1	Plat et al.	04-01-2003	
	E23	2003/0081193	A1	White et al.	05-01-2003	
	E24	2003/0080471	A1	Chou	05-01-2003	
	E25	2004/0036201	A1	Chou et al.	02-26-2004	
	E26	5,468,542		Crouch	11-21-1995	
	E27	5,366,851		Novembre	11-22-1994	
	E28	5,362,606		Hartney et al.	11-08-1994	
	E29	5,324,683		Fitch et al.	06-28-1994	
	E30	5,212,147		Sheats	05-18-1993	
	E31	5,458,520		DeMercurio et al.	10-17-1995	
	E32	5,453,157		Jeng	09-26-1995	
	E33	5,439,766		Day et al.	08-08-1995	
	E34	5,431,777		Austin et al.	07-11-1995	
Examiner Signature	Sang H. Nguyen				Date Considered	09/11/05

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)			Application Number	09/920,341
			Filing Date	08/01/2001
			First Named Inventor	Choi et al.
			Group Art Unit	2877
			Examiner Name	Nguyen, Sang H.
			Attorney Docket Number	PA17-07V06
Sheet	2	of	7	

U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
SN	E35	5,422,295		Choi et al.	06-06-1995	
	E36	5,421,981		Leader et al.	06-06-1995	
	E37	5,417,802		Obeng	05-23-1995	
	E38	5,380,474		Rye et al.	01-10-1995	
	E39	5,374,454		Bickford et al.	12-20-1994	
	E40	5,330,881		Sidman et al.	07-19-1994	
	E41	5,328,810		Lowrey et al.	07-12-1994	
	E42	5,318,870		Hartney	06-07-1994	
	E43	5,244,818		Jokerst et al.	09-14-1993	
	E44	5,242,711		DeNatale et al.	09-07-1993	
	E45	5,240,878		Fitzsimmons et al.	08-31-1993	
	E46	5,108,875		Thackeray et al.	04-28-1992	
	E47	5,053,318		Gulla et al.	10-01-1991	
	E48	4,964,945		Calhoun	10-23-1990	
	E49	4,908,298		Hefferon et al.	03-13-1990	
	E50	4,921,778		Thackeray et al.	05-01-1990	
	E51	4,919,748		Bredbenner et al.	04-24-1990	
	E52	3,783,520		King	01-08-1974	
E53	6,776,094	B1	Whitesides et al.	08-17-2004		
E54	4,201,800		Alcorn et al.	05-06-1980		
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E57	4,552,833		Ito et al.	11-12-1985		
E58	4,657,845		Frechet et al.	04-14-1987		
E59	4,692,205		Sachdev et al.	09-08-1987		
E60	4,707,218		Giammarco et al.	11-17-1987		
E61	4,737,425		Lin et al.	04-12-1988		
E62	4,808,511		Holmes	02-28-1989		
E63	4,826,943		Ito et al.	05-02-1989		
E64	4,857,477		Kanamori	08-15-1989		
E65	4,891,303		Garza et al.	01-02-1990		
E66	4,931,351		McColgin et al.	06-05-1990		
E67	4,976,818		Hashimoto et al.	12-11-1990		
E68	4,980,316		Huebner	12-25-1990		
Examiner Signature	Sang H. Nguyen				Date Considered	04/11/05

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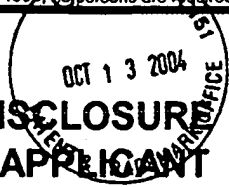
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Substitute for form 1449A/PTO				Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)				Application Number	09/920,341
Sheet	3	of	7	Examiner Name	Nguyen, Sang H.
				Attorney Docket Number	PA17-07V06

U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
SN	E69	4,999,280		Hiraoka	03-12-1991	
	E70	5,071,694		Uekita et al.	12-10-1991	
	E71	5,169,494		Hashimoto et al.	12-08-1992	
	E72	5,173,393		Sezi et al.	12-22-1992	
	E73	5,198,326		Hashimoto et al.	03-30-1993	
	E74	5,234,793		Sebald et al.	08-10-1993	
	E75	5,314,772		Kozicki et al.	05-24-1994	
	E76	5,527,662		Hashimoto et al.	06-18-1996	
	E77	5,654,238		Cronin et al.	08-05-1997	
	E78	5,700,626		Lee et al.	12-23-1997	
	E79	5,736,424		Prybyla et al.	04-07-1998	
	E80	5,895,263		Carter et al.	04-20-1999	
	E81	5,907,782		Wu	05-25-1999	
	E82	5,926,690		Toprac et al.	07-20-1999	
	E83	5,948,570		Kornblit et al.	09-07-1999	
	E84	6,033,977		Gutsche et al.	03-07-2000	
	E85	6,096,655		Lee et al.	08-01-2000	
	E86	6,150,231		Muller et al.	11-21-2000	
	E87	6,245,581	B1	Bonser et al.	06-12-2001	
	E88	6,274,294	B1	Hines	08-14-2001	
	E89	6,329,256	B1	Ibok	12-11-2001	
	E90	6,383,928	B1	Elssa	05-07-2002	
	E91	6,387,783	B1	Furukawa et al.	05-14-2002	
	E92	6,388,253	B1	Su	05-14-2002	
	E93	6,391,798	B1	DeFelice et al.	05-21-2002	
	E94	6,455,411	B1	Jiang et al.	09-24-2002	
	E95	6,489,068	B1	Kye	12-03-2002	
	E96	6,514,672	B2	Young et al.	02-04-2003	
	E97	6,561,706	B2	Singh et al.	05-13-2003	
	E98	6,565,928	B2	Sakamoto et al.	05-20-2003	
SN	E99	2003/011368	A1	Mancini et al.	06-19-2003	
	E100	2003/0129542	A1	Shih et al.	07-10-2003	
	E101	6,632,742	B2	Yang et al.	10-14-2003	
	E102	6,635,581	B2	Wong	10-21-2003	
Examiner Signature	Sang H. Nguyen				Date Considered	08/11/05

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Sheet

4

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7

Complete if Known

Application Number	09/920,341
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Filing Date	08/01/2001
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First Named Inventor	Choi et al.
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Group Art Unit	2877
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Examiner Name	Nguyen, Sang H.
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Examiner Signature	<i>Sanghyun</i>	Date Considered	04/11/05
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		Attorney Docket Number	PA17-07V06
Sheet	6	of	7

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
SN	E114	Abstract of Japanese Patent 63-138730	
	E115	Abstract of Japanese Patent 55-88332	
	E116	Abstract of Japanese Patent 57-7931	
	E117	Abstract of Japanese Patent 02-92603.	
	E118	Translation of Japanese Patent 02-92603.	
	E119	Abstract of Japanese Patent 02-24848.	
	E120	Translation of Japanese Patent 02-24848.	
	E121	HEIDARI et al., "Nanoimprint Lithography at the 6 in. Wafer Scale," Journal of Vacuum Science Technology, Nov/Dec 2000, pp. 3557-3560, vol. B, no. 18(6)	
	E122	NERAC.COM Retro Search, "Reduction of Dimension of Contact Holes", August 31, 2004	
	↓	E123	NERAC.COM Retro Search, "Trim Etching of Features Formed on an Organic Layer", September 2, 2004
SN	E124	NERAC.COM Retro Search, "Multi-Layer Resists", September 2, 2004	

Examiner Signature	<i>Sang H. Nguyen</i>	Date Considered	08/11/01
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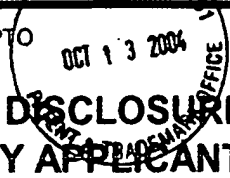
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Substitute for form 1449B/PTO				Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)		Application Number		09/920,341	
		Filing Date		08/01/2001	
		First Named Inventor		Choi et al.	
		Group Art Unit		2877	
		Examiner Name		Nguyen, Sang H.	
Sheet	7	of	7	Attorney Docket Number PA17-07V06	

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SN	E125	HU et al., "Flourescence Probe Techniques (FPT) for Measuring the Relative Efficiencies of Free-Radical Photoinitiators", s0024-9297(97)01390-9; "Macromolecules" 1998, vol. 31, no.13, pp. 4107-4113, 1998 American Chemical Society. Published on Web 05/29/1998	
SN	E126	FEYNMAN, Richard P., "There's Plenty of Room at the Bottom—An Invitation to Enter a New Field of Physics," 12 pp [online]Retreived 9/23/04 from URI:http://www.zyvex.com/nanotech/feynman.html.	
SN	E127	CIBA SPECIALTY CHEMICALS BUSINESS LINE COATINGS, "What is UV Curing?", 45 pp [online]Retreived 9/24/04 from URL:http://www.cibasc.com/image.asp?id=4040.	

Examiner Signature		Date Considered	04/11/05
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Sheet

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3

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Application Number

09/920,341

Filing Date

08/01/2001

First Named Inventor

Choi et al.

Group Art Unit

2877

Examiner Name

Nguyen, Sang H.

Attorney Docket Number

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U.S. PATENT DOCUMENTS

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Sheet	2	of	3
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Application Number	09/920,341
Filing Date	08/01/2001
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Examiner Name	Nguyen, Sang H.
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Application Number	09/920,341
Filing Date	08/01/2001
First Named Inventor	Choi et al.
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Examiner Signature	<i>[Signature]</i>	Date Considered	<i>05/11/05</i>
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